

Topological Photonics Research at Sandia Labs

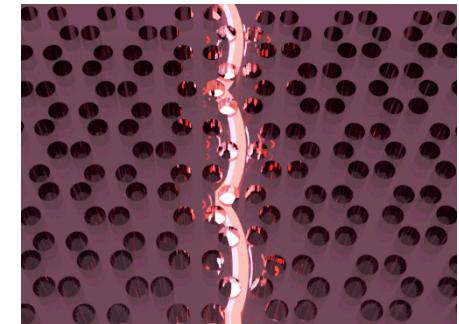
Ganapathi Subramania

Collaborators: P. Duke Anderson*+, Daniel D. Koleske*

*Sandia National Laboratories, Albuquerque, NM

+ University of Southern California, Los Angeles, CA

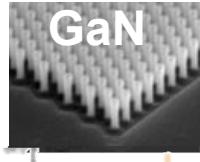
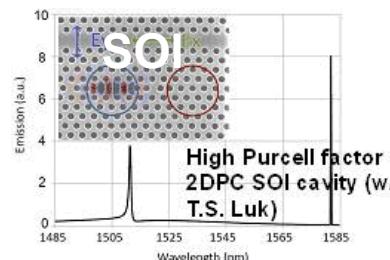
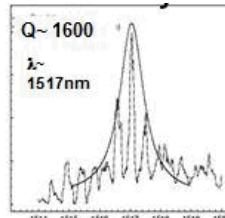
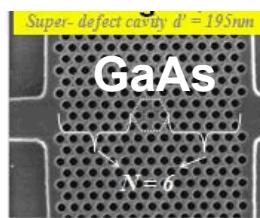
Jan 8-13, 2017
Physics of Quantum Electronics
Snowbird, UT



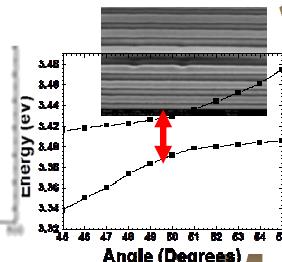
Sandia National Laboratories is a multi-mission laboratory managed and operated by Sandia Corporation, a wholly owned subsidiary of Lockheed Martin Corporation, for the U.S. Department of Energy's National Nuclear Security Administration under contract DE-AC04-94AL85000.

Nanophotonics Activity

Integrated Photonics, Nanoscale lasing, Strong coupling, Full 3D emission control, Thermal control, Solid State lighting, Energy conversion



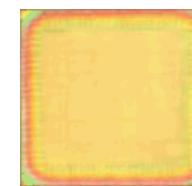
Strong coupling
(w/A. Fischer)



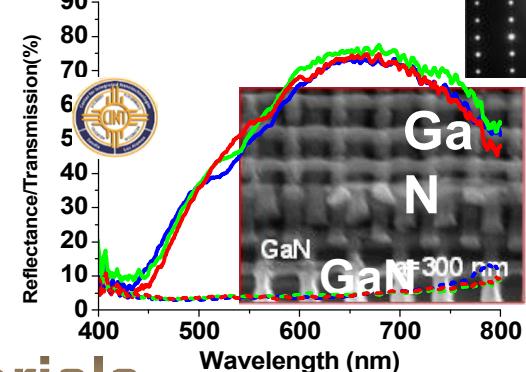
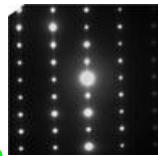
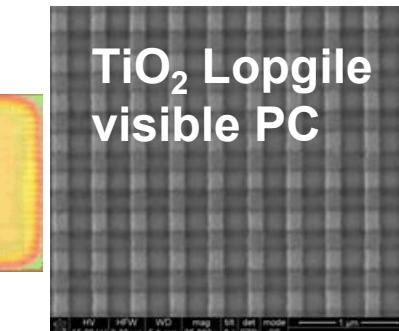
1,2D PC

Photonic
Nanostructur

3D PC

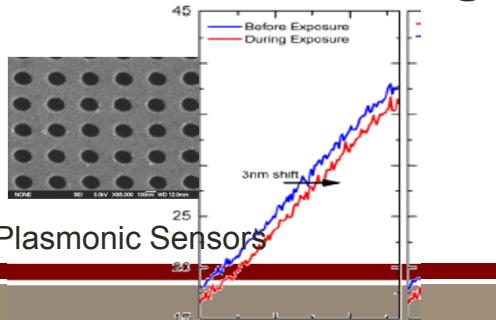


TiO₂ Logpile
visible PC

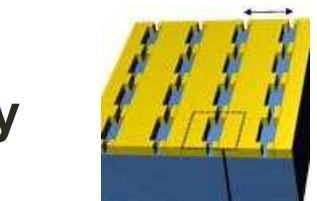
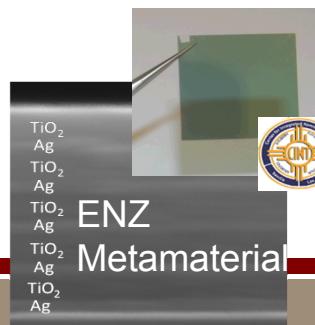


GaN 2DPC laser w/ G. Wang, I. Metal optics and Metamaterials

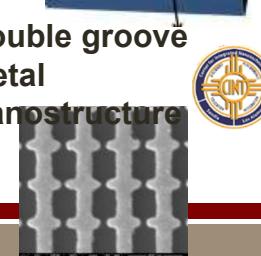
Brener
Ultrasubwavelength light control,
Detection, Sensing , Nanocircuitry



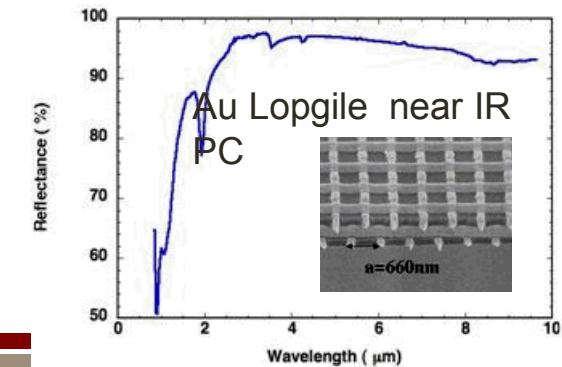
Plasmonic Sensors



Double groove
Metal
Nanostructure



Reflectance (%)



Outline

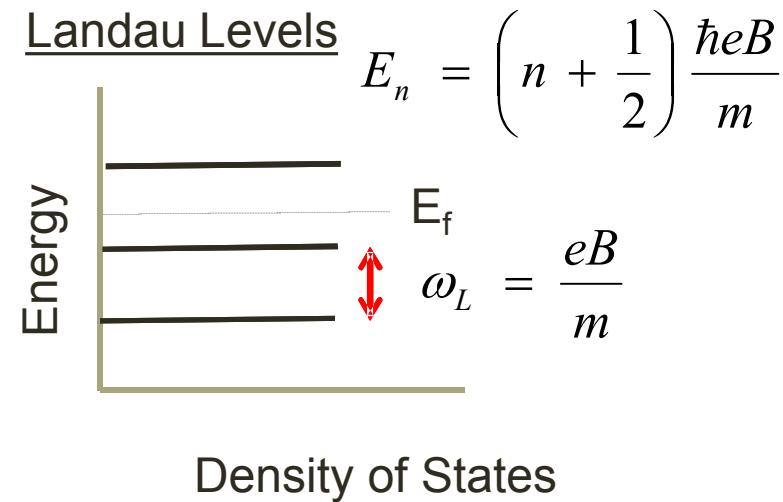
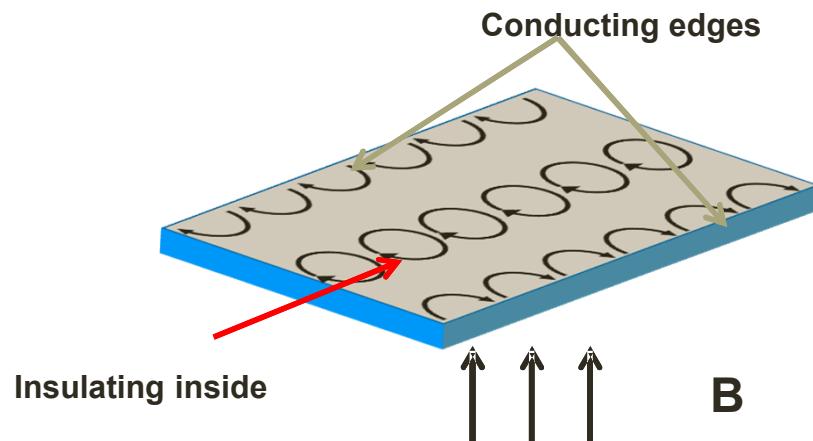
- Introduction
- Designs for photonic spin hall effect
 - Modified honeycomb lattice
 - Rod vs. Hole array structure
- Fabrication approach
 - Passive devices
 - Active devices
- Summary and Future directions

Topological Systems in Electronics

Electronic Topological Insulators : Systems exhibiting Quantum Hall Effect \rightarrow 2DEGs

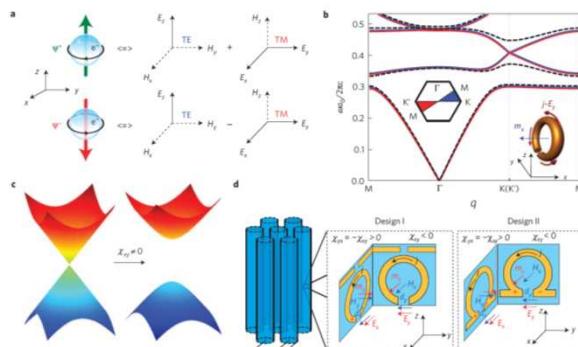
Time reversal symmetry is broken by applying magnetic (B) field

- Discrete highly degenerate Landau Levels
 - Conducting edge states within insulator gap
 - Topologically protected “one way” electronic transport
- *Needs high B fields*
 - *Low temperatures*



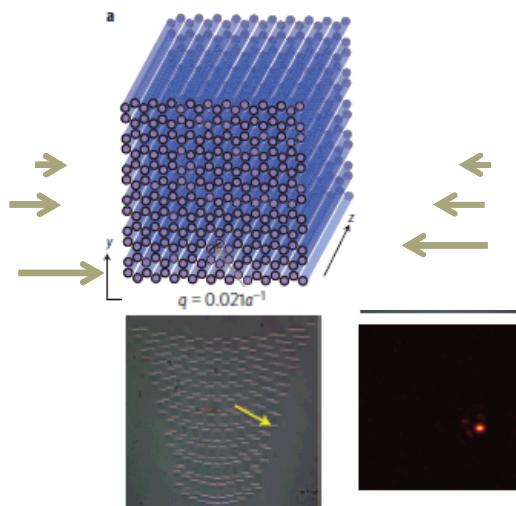
It turns out appropriately designed photonic structures can exhibit similar topological properties too!

Topological Photonics Research Activities



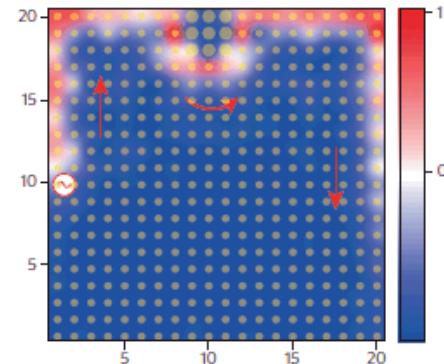
A. B. Khanikaev et.al. Nat Mater **12** (3), 233-239 (2013).

Strain induced pseud mag. field
in optical fiber arrays and edge transport

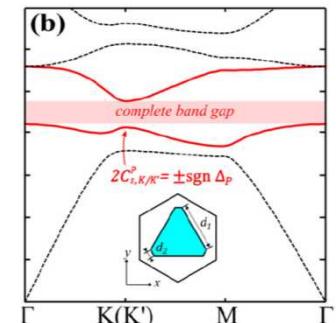


M. Rechtsman et.al. Nat. Phot. **7** (2013) 

Simulation of Oneway edge transport

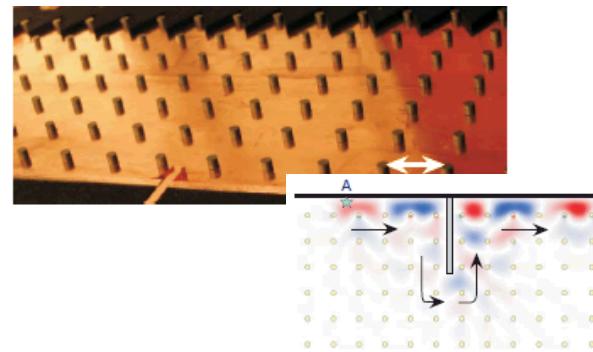


K. Fang, Z. Yu , S.H.Fan ,
Nat. Phot. **6** , (2012)

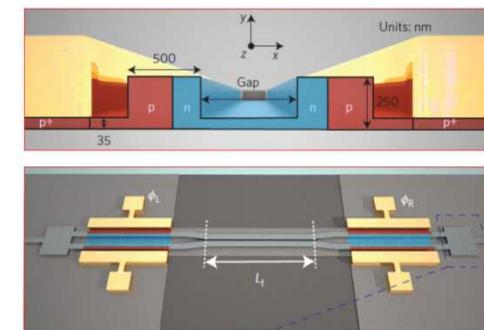


M. Tzuhsuan and S. Gennady, New
Journal of Physics **18** (2), 025012 (2016).

One- way scatter transport at microwave
frequency $\sim 4\text{GHz}$ in 2DPCs



Z. Wang et. al. Nat. **461** (2009) 



D. Tzeng, et. al. Nat Photon **8** (9),
701-705 (2014).

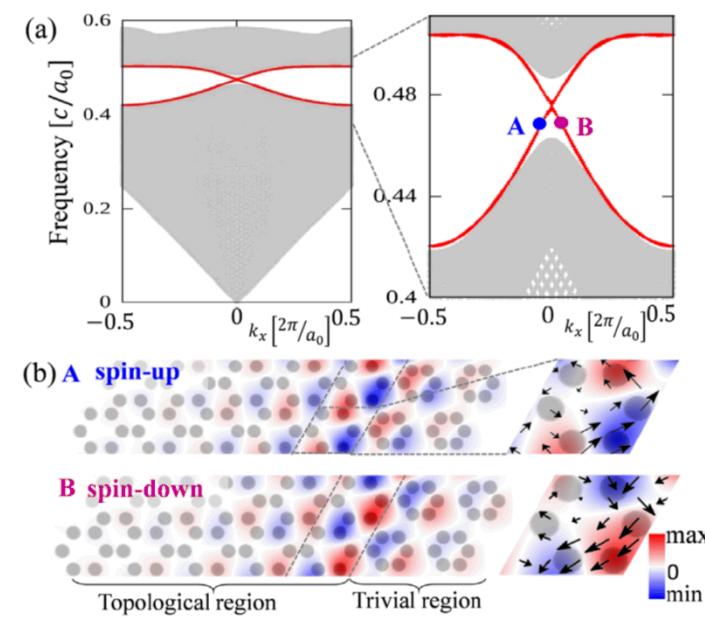
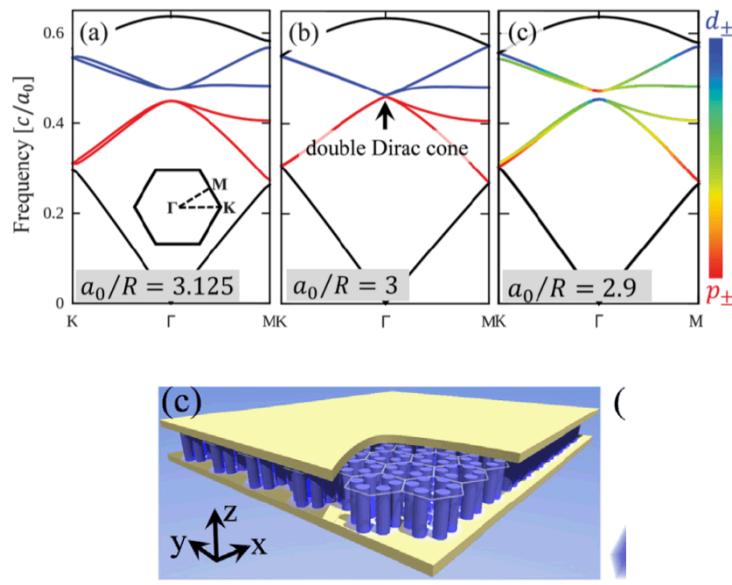
Scheme for Achieving a Topological Photonic Crystal by Using Dielectric Material

Long-Hua Wu and Xiao Hu*

International Center for Materials Nanoarchitectonics (WPI-MANA), National Institute for Materials Science, Tsukuba 305-0044, Japan

Graduate School of Pure and Applied Sciences, University of Tsukuba, Tsukuba 305-8571, Japan

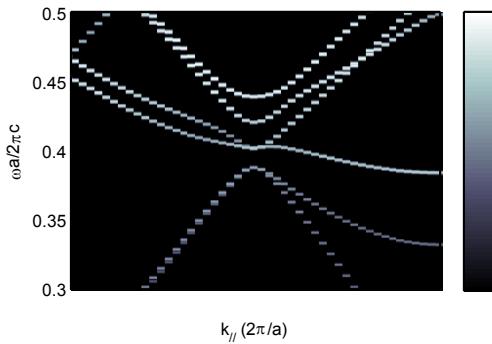
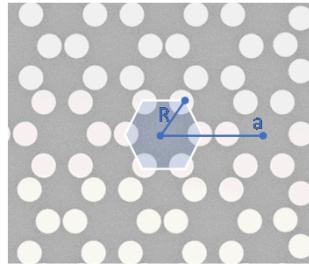
(Received 10 February 2015; published 3 June 2015)



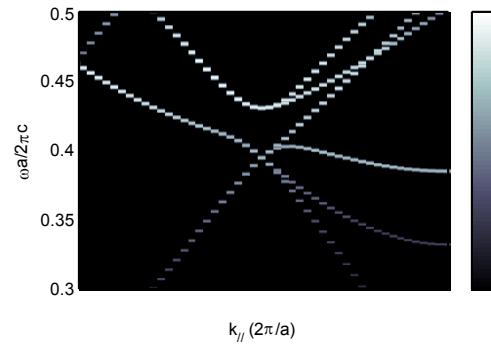
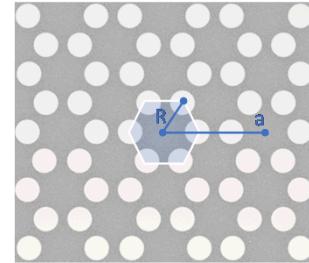
Modified honeycomb lattice of dielectric rods

Photonic Bandstructures for Modified Honeycomb Lattices

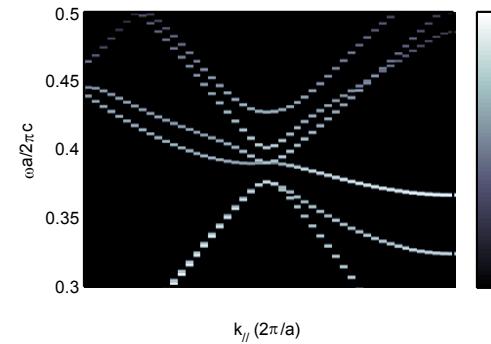
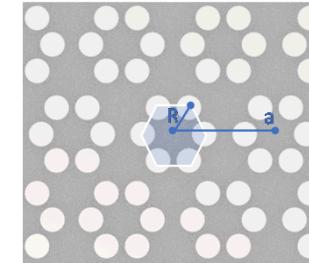
- Holes in dielectric design can be useful for optical frequency photonics applications



Trivial ($a/R = 2.9$)



Honeycomb ($a/R = 3.0$)



Topological ($a/R = 3.2$)

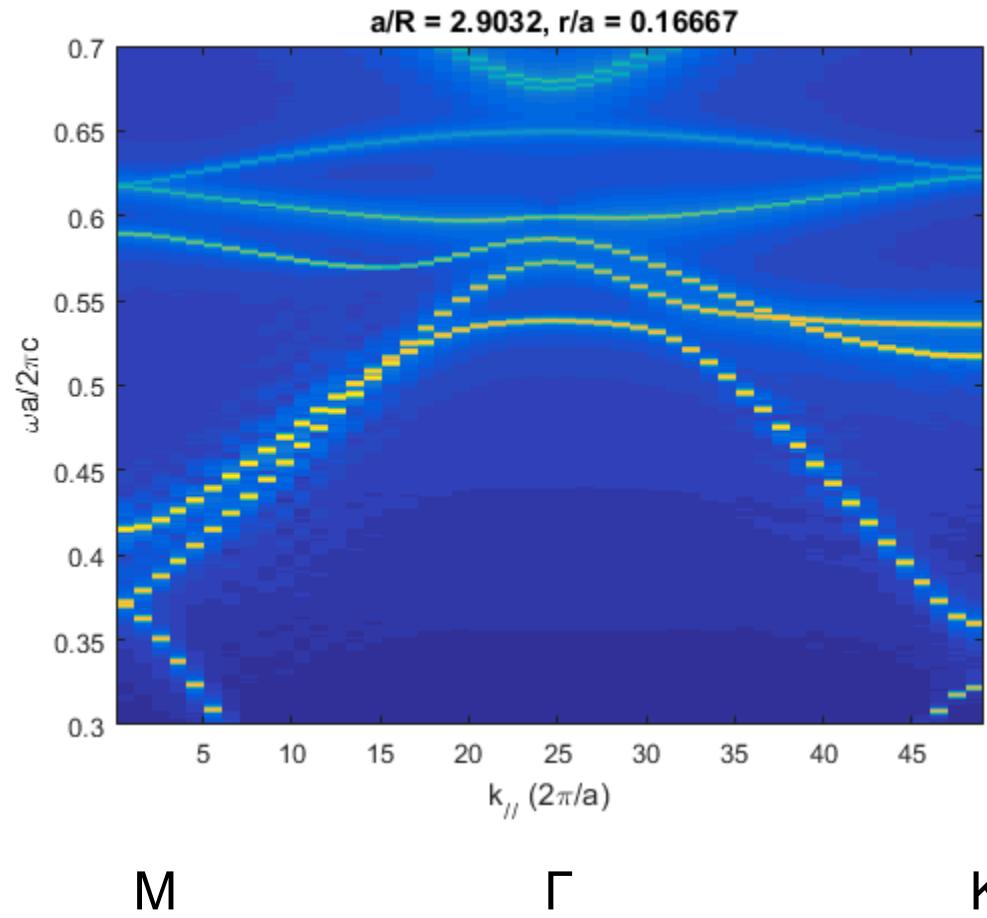
$(r/a \sim 0.12)$

Does not open up a band gap !

Calculated with FDTD
(Lumerical ®)

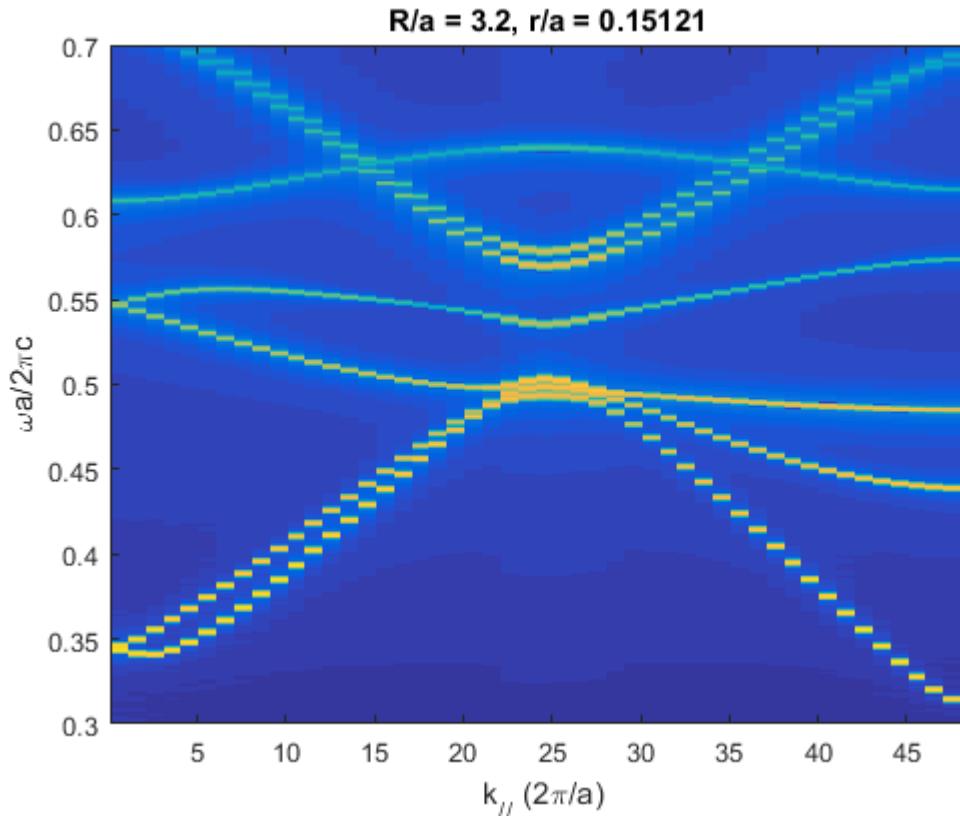
Band structure for Trivial Lattice ($a/R < 3.0$) varying r/a)

For $\lambda = 1550 \text{ nm}$, $a \sim 900 \text{ nm}$



Band structure for Topological Lattice ($a/R > 3.0$) varying r/a

For $\lambda = 1550 \text{ nm}$, $a \sim 900 \text{ nm}$

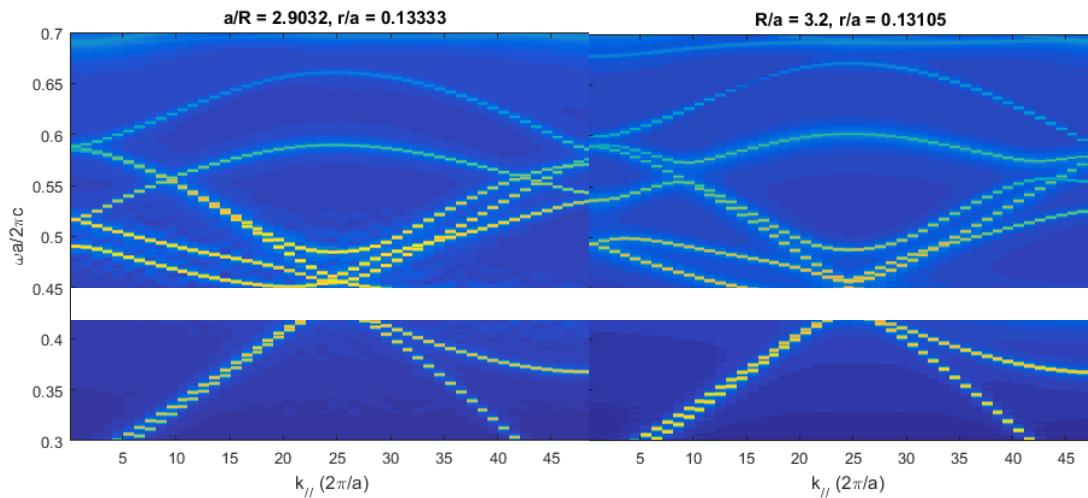


M

Γ

K

Band gap alignment for Topological/Trivial Interface



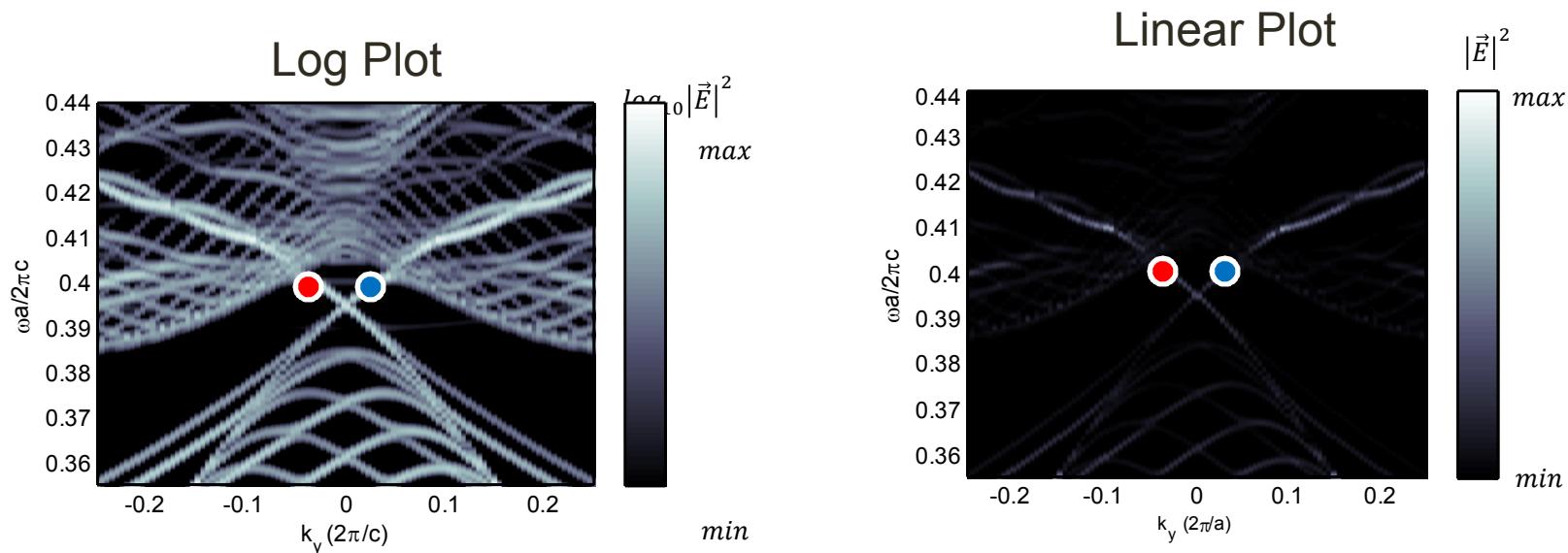
Let's assume that **a = 700 nm** and **$\lambda = 1550 \text{ nm}$** ($\omega a / 2\pi c \sim 0.45$)

Assuming equal lattice constants: **$R_{\text{triv}} = 241 \text{ nm}$** and **$R_{\text{top}} = 218 \text{ nm}$**

Lastly, **$d_{\text{triv}} = 187 \text{ nm}$** and **$d_{\text{top}} = 183 \text{ nm}$**

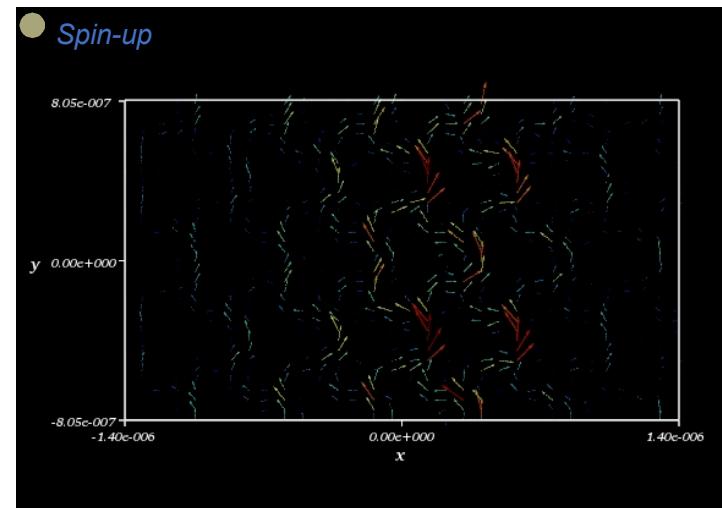
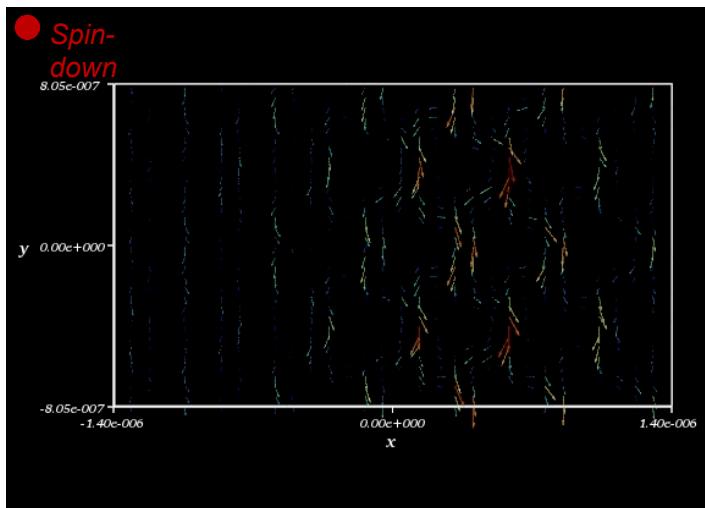
Band structure for Topological/Trivial Zig-zag Interface

$R_{triv}/a = 0.312$, $R_{top}/a = 0.344$, $r/a = 0.12$, $a = 700$ nm



- Crossing unidirectional edge states are observed
- Other modes show up in the band structure as well

Power/Vector Plots of Edge States

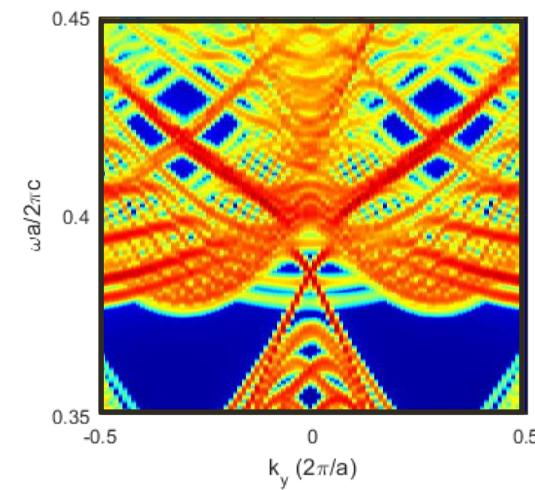
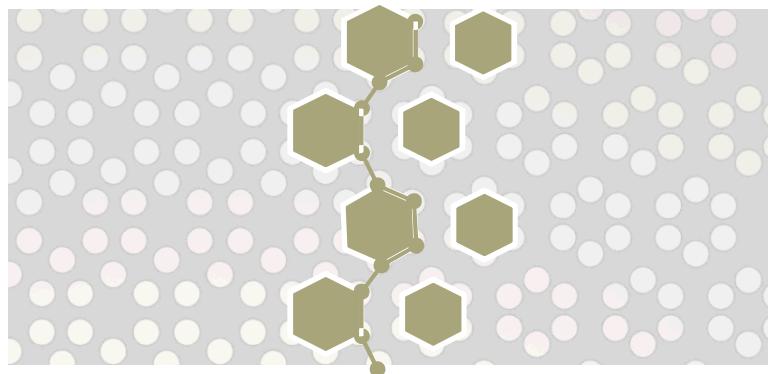


Band structure for Topological/Trivial Armchair Interface

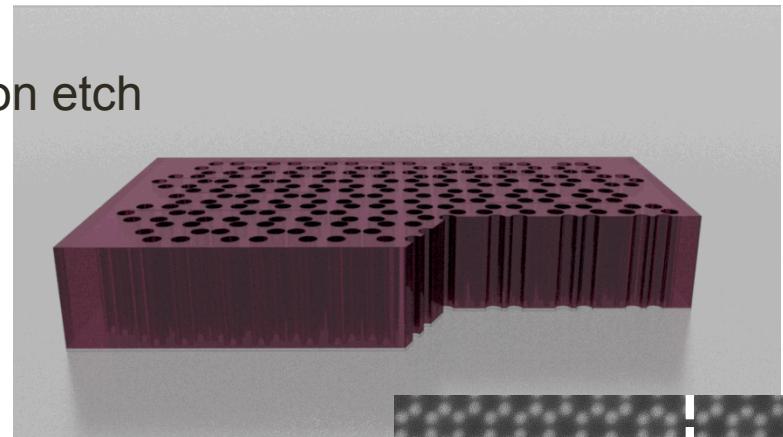
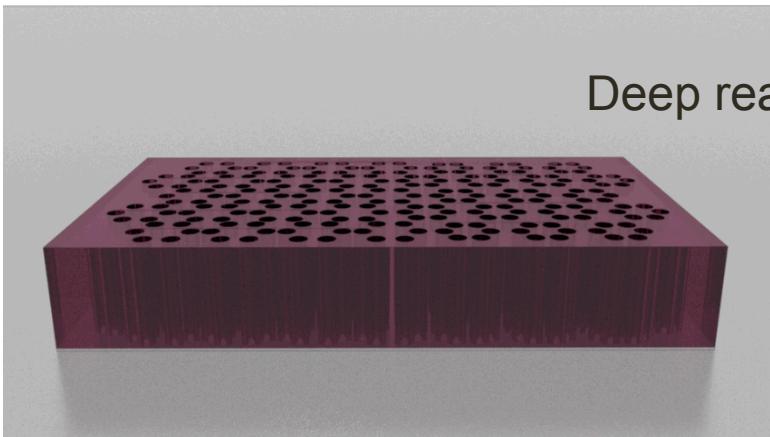
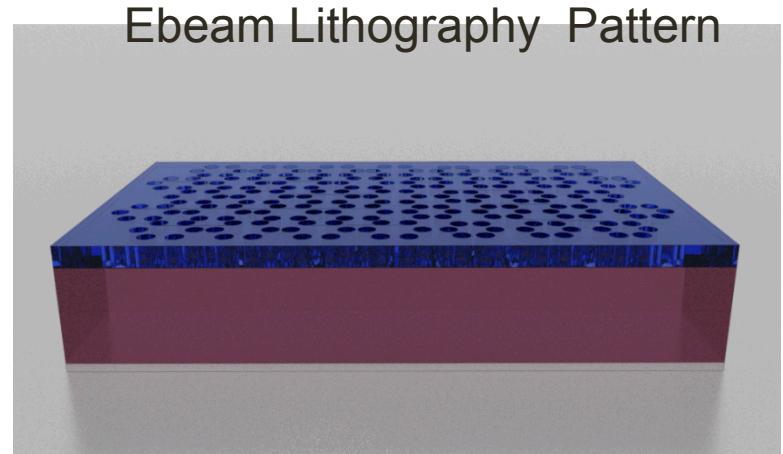
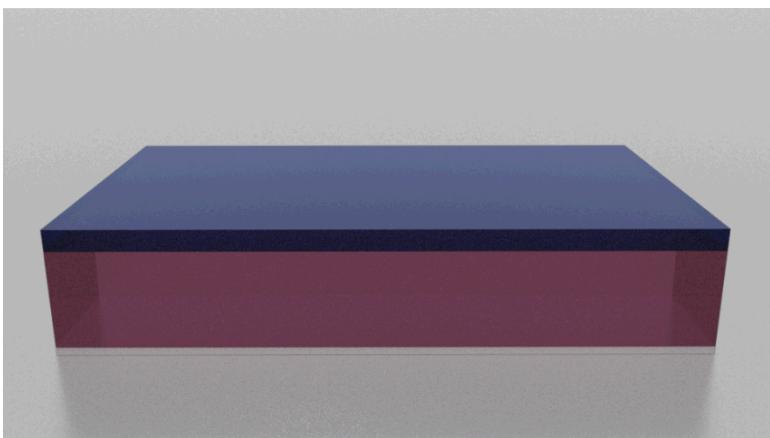
Ribbon/Interface Photonic Band Structure

$R_{triv}/a = 0.312$, $R_{top}/a = 0.344$, $r/a = 0.12$, $a = 700$
nm

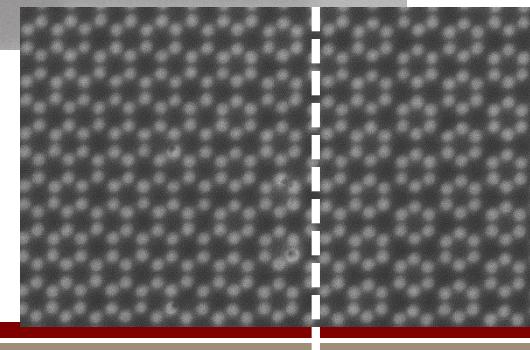
ArmChair-like Interface



Fabrication on Thick Si using deep etch

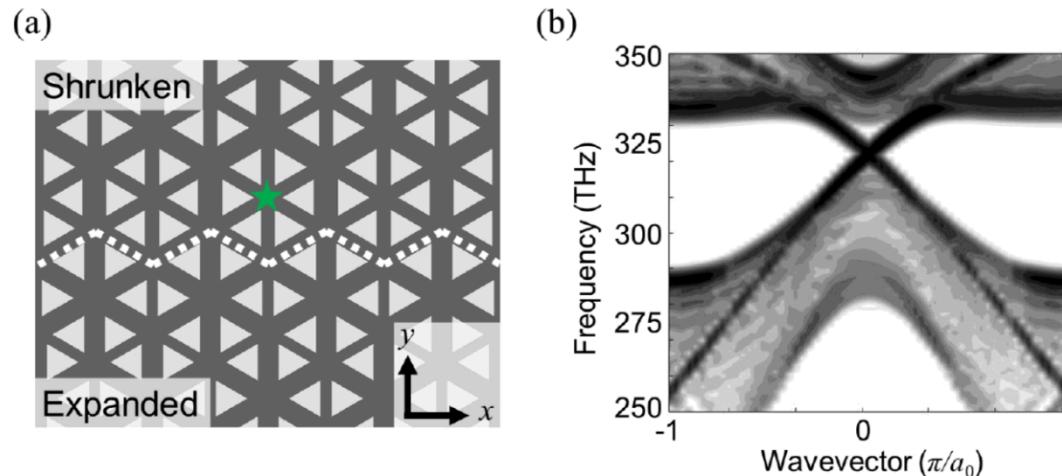


SEM image



Two-Dimensionally Confined Topological Edge States in Photonic Crystals

Sabyasachi Barik^{1,2}, Hirokazu Miyake², Wade DeGottardi², Edo Waks^{2,3}, Mohammad Hafezi^{2,3,4}



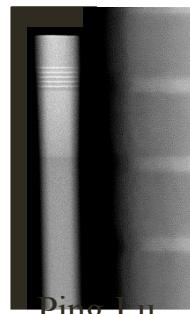
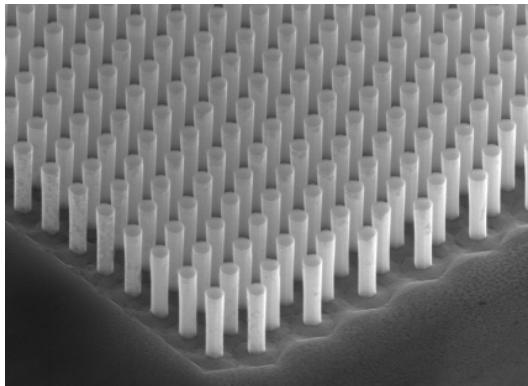
Fabrication could be challenging

Topological structure in active material systems

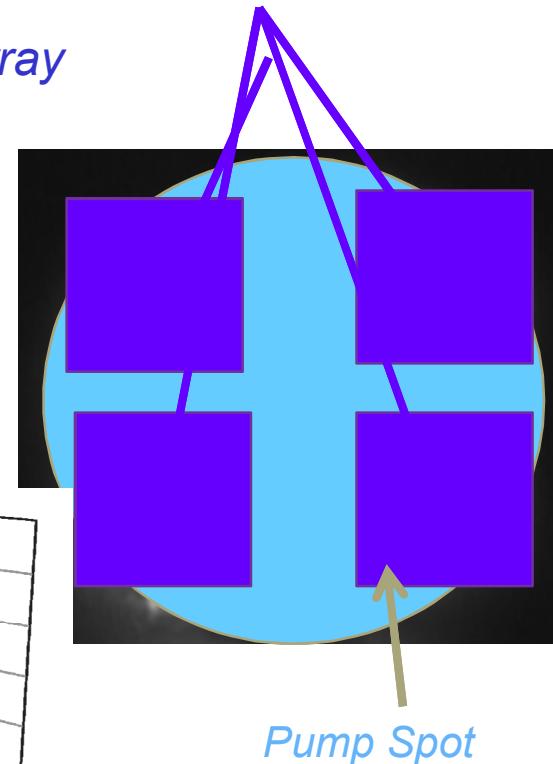
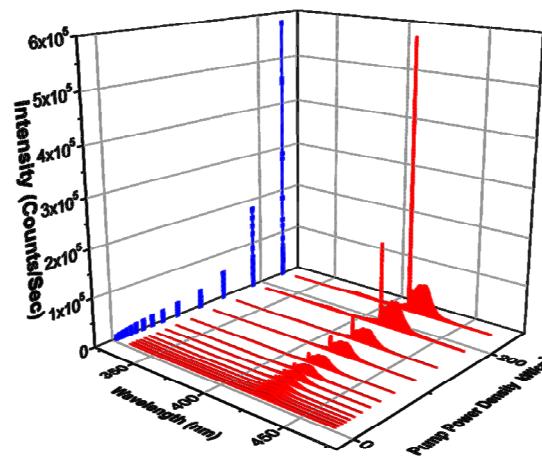
III-nitride material with InGaN Quantum wells

Photonic Crystal Laser Pixels

Demonstration of Lasing from PhC Array



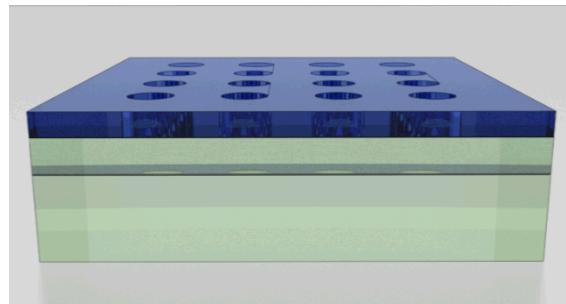
Ping Lu,
Sandia



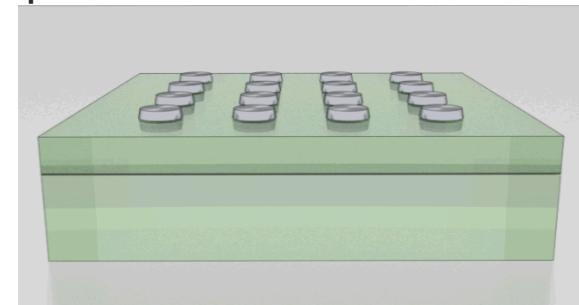
Light sources with interesting angular momentum properties ?

Fabrication procedure in GaN

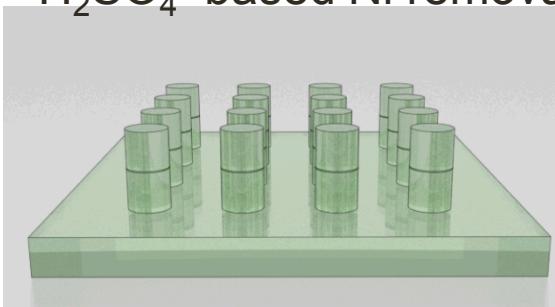
EBL pattern in
PMMA



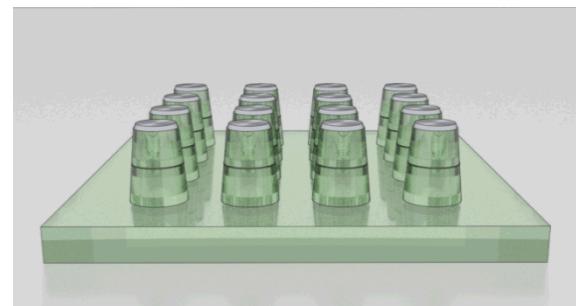
Ni evaporation and lift-off



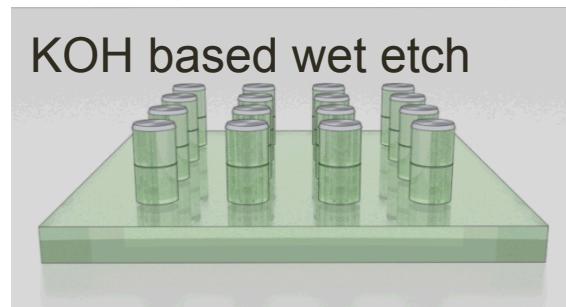
H_2SO_4 -based Ni removal



Cl2 based dry etch



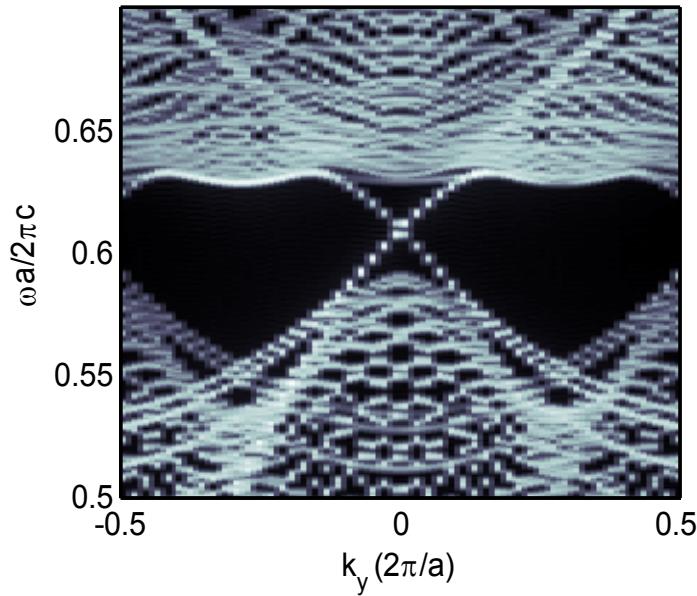
KOH based wet etch



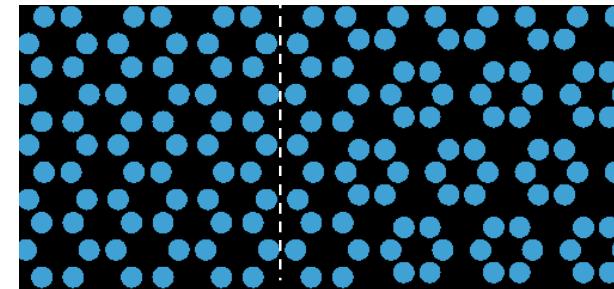
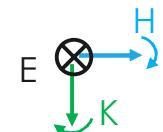
Topological edge state in honeycomb lattice structure in III-Nitride

Modeling

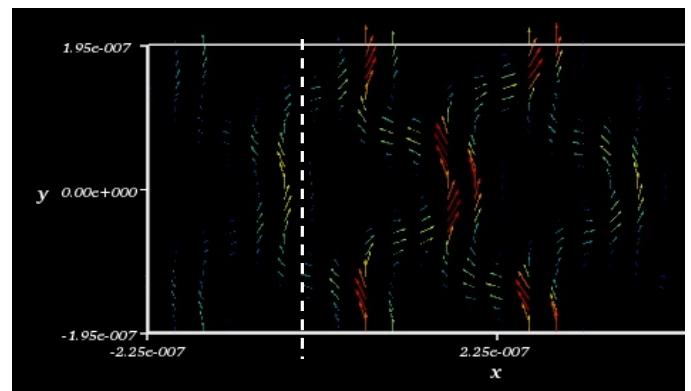
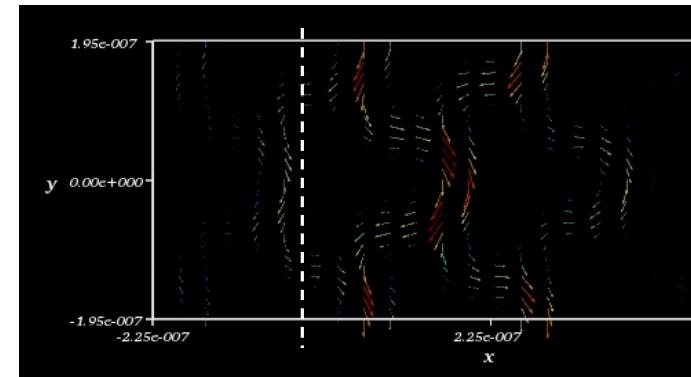
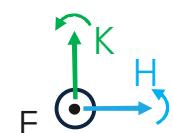
Band Structure



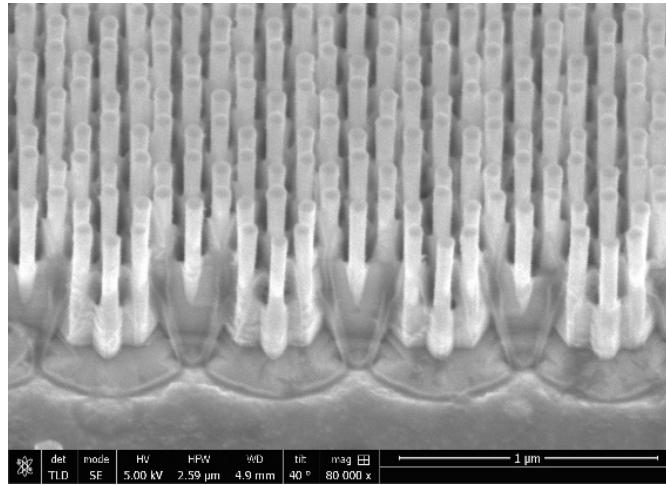
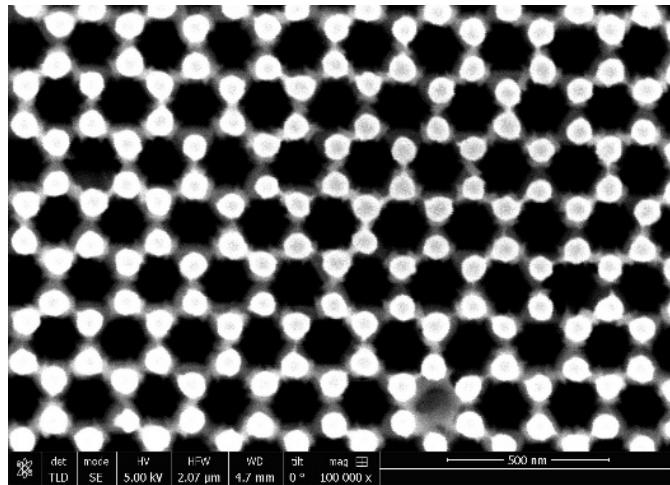
Spin-down state
 $a/\lambda = 0.618$



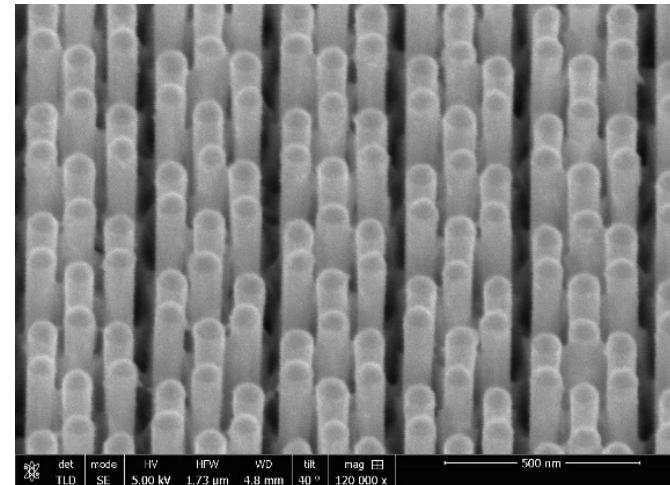
Spin-up state
 $a/\lambda = 0.60$



Fabricated Topological/Trivial lattice interface structure in III-Nitride



- Main challenge
- Source polarization



Summary and Future directions

- Hole array honey comb lattice structure for photonic pseudo spin
- Fabrication in III-nitride
- Fabrication in Silicon/SOI
- Optical measurement to demonstrate pseudo spin

Thank you for your attention!

Fabrication on Silicon on Insulator (SOI) - Membrane

SOI Device Fabrication (Membrane)

